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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

the Application of

Takeshi KIJIMA et al.

Application No.: 10/722,422

Filed: November 28, 2003

Docket No.: 117897

For: METHOD OF MANUFACTURING CERAMIC FILM, METHOD OF MANUFACTURING FERROELECTRIC CAPACITOR, CERAMIC FILM, FERROELECTRIC CAPACITOR, AND SEMICONDUCTOR DEVICE (AS AMENDED)

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- 2. An English-language Abstract of the non-English language reference is attached hereto.
- 3. A co-pending U.S. patent application is identified on Form PTO 1449 of this Information Disclosure Statement. The Examiner is respectfully requested to consider the cited application and the art cited therein during examination of the present application.

Respectfully submitted,

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Date: July 22, 2004

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DEPOSIT ACCOUNT USE AUTHORIZATION
Please grant any extension necessary for entry;
Charge any fee due to our Deposit Account No. 15-0461



Sheet 1 of 1

Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE	ATTY DOCKET NO. 117897	APPLICATION NO. 10/722,422	
INFORMATION DISCLOSURE STATEMENT  (Use several sheets if necessary)					
		APPLICANTS Takeshi KIJIMA et al.			
		FILING DATE November 28, 2003			
U.S. PATENT DOCUMENTS					
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS
	1)	10/793,889	03/08/2004	KIJIMA et al.	
FOREIGN PATENT DOCUMENTS					
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS
	2)	WO 00/17929 w/ abstract	03/30/2000	WIPO	
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)					
EXAMINER				DATE CONSIDERED	
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.					